



AFW

Docket No.: 8733.213.00
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Jin JANG et al.

Customer No.: 30827

Application No.: 09/497,508

Confirmation No.: 7572

Filed: February 4, 2000

Art Unit: 2814

For: **POLYCRYSTALLINE SILICON FILM
CONTAINING Ni**

Examiner: Wai Sing Louie

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the final Office Action dated April 19, 2006, please amend the patent application identified above as follows:

INTRODUCTORY COMMENTS

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 3 of this paper.